



Appl. No. 09/602,395

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/602,395
Filing Date June 22, 2000
Inventor John T. Moore
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Pham, Thanhha S.
Attorney's Docket No. MI22-1384
Title: Methods of Forming Oxide Regions Over Semiconductor Substrates

RESPONSE TO DECEMBER 4, 2003 FINAL OFFICE ACTION
TO ACCOMPANY RCE FILING

To: Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS

Introductory Comments

In response to the Office Action dated December 4, 2003, applicant amends and remarks as follows.